

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Shinichi Kurita et al.
Serial No. : 10/782,503
Filed : February 19, 2004
For : METHODS AND APPARATUS FOR DETERMINING A
POSITION OF A SUBSTRATE RELATIVE TO A
SUPPORT STAGE
Examiner : Emily Y. Chan
Group Art Unit : 2829
Customer No. : 41161
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

In response to the Examiner's Office Action dated
March 26, 2007, applicants amend the above-identified
application as follows:

Listing of the Claims begins on page 2.

Remarks begin on page 9.